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Bib Data Sheet

CONFIRMATION NO. 3276

<b>SERIAL NUMBER</b> 09/494,327	<b>FILING DATE</b> 01/28/2000 <b>RULE</b>	<b>CLASS</b> 134 156	<b>GROUP ART UNIT</b> 1746	<b>ATTORNEY DOCKET NO.</b> 4209
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## APPLICANTS

Michael Chiu Kwan, Redwood City, CA;  
Alan W. Collins, San Francisco, CA;  
Jalel Hamilia, San Jose, CA;  
Padmanabhan Krishnaraj, San Francisco, CA;  
Zhengquan Tan, Cupertino, CA;

\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/27/2000

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWING</b> 2	<b>TOTAL CLAIMS</b> 15	<b>INDEPENDENT CLAIMS</b> 3
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i> Initials				

## ADDRESS

#16 92588

Patent Counsel Applied Materials, Inc.  
P.O. Box 450 A Santa Clara CA 95052

## TITLE

Method and apparatus for cleaning a semiconductor wafer processing system

<b>FILING FEE RECEIVED</b> 820	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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